

Notice of References Cited	Application/Control No. 10/519,623	Applicant(s)/Patent Under Reexamination MURRELL, ADRIAN	
	Examiner Meenakshi S. Sahu	Art Unit 2809	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,093,456	07-2000	England et al.	427/523
*	B	US-6,392,245	05-2002	Edwards et al.	250/492.21*
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Murrell, A., Wauk, M. Clarke, N. Burgin, D. Scotney-Castle, M Lee, R.M. Carpentier, K. Harrington, K. "Dopant Cross-Contamination Reduction with a 3-Position Beamstop", 1997, Proceedings of the 11th International Conference on Ion Implantation Technology, pages 147 - 150
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.